Special Issue

Ultra-Precision Manufacturing Technology

Message from the Guest Editor

Ultraprecision is not only a cutting-edge technology but also one of the most important issues in the current manufacturing field. In this Special Issue, we seek papers in a boundary of ultraprecision manufacturing technology, not limited to mechanical-based processes. Ultraprecision manufacturing technology covers a broad scope involving manufacturing processes, machine tool design, nontraditional process, additive manufacturing processes, hybrids, theoretical study, and metrology. In addition, we welcome research works including multidisciplinary (physical, chemical, biological, micro/nano) manufacturing technologies such as highenergy beam processes, photolithography, nontraditional and alternative micro/nanofabrication. nanomaterial processes, and biomedical fabrication, All types of papers, such as original research papers, review articles are acceptable.

Guest Editor

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Deadline for manuscript submissions

closed (30 August 2022)



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Editor-in-Chief

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